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SO 16063-31:2009/Amd 1:2025

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#### ISO 16063-31:2009/Amd.1:2025(en)

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This document was prepared by Technical Committee ISO/TC 108, *Mechanical vibration, shock and condition monitoring*.

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# Methods for the calibration of vibration and shock transducers —

## Part 31: **Testing of transverse vibration sensitivity**

## **AMENDMENT 1**

7.3

Add the following subclause at the end of Clause 7:

#### "7.3 Determination of the transverse sensitivity using elliptical orbits

Annex B shall be used for testing of transverse sensitivity using elliptical orbits."

Annex B



Add the following annex after Annex A, before the Bibliography.

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## Annex B (normative)

### Testing of transverse sensitivity using elliptical orbits

This annex gives a brief insight into a method that can be used to test the transverse sensitivity of vibration and shock transducers in the bi-axial transverse directions by actuating the test set up exciters in the X- and Y- directions at any phase and amplitude as described in Formulae (B.1) and (B.2). A full description of a method that can be used is included in Reference [13].

$$a_{\rm X}\left(t\right) = \hat{a}_{\rm X}\cos\left(2\pi f t + \phi_{\rm X}\right) \tag{B.1}$$

$$a_{\rm Y}\left(t\right) = \hat{a}_{\rm Y}\cos\left(2\pi f t + \phi_{\rm Y}\right) \tag{B.2}$$

where

$a_{\mathbf{v}}(t)$	is the time-varying value of the X-axis acceleration;
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 $\hat{a}_{\mathbf{x}}$  is the amplitude of the acceleration component along the X-axis;

 $\phi_{\rm X}$  is the initial phase of the acceleration component along the X-axis;

 $a_{\rm v}(t)$  is the time-varying value of the Y-axis acceleration;

 $\hat{a}_{v}$  is the amplitude of the acceleration component along the Y-axis;

 $\phi_{\rm v}$  is the initial phase of the acceleration component along the Y-axis;

*f* is the frequency of oscillation; and 31:2009/Amd 1:2025

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In general case, Formulae (B.1) and (B.2) describe an elliptical orbit motion in the X-Y plane and in those cases the transducer under test output is given by Formula (B.3).

$$V_{\rm T}(t) = S_{\rm X}\hat{a}_{\rm X}\cos\left(2\pi ft + \phi_{\rm X}\right) + S_{\rm Y}\hat{a}_{\rm Y}\cos\left(2\pi ft + \phi_{\rm Y}\right) \tag{B.3}$$

where

 $S_{\rm X}$  is the transverse sensitivity in the X-direction;

 $S_{v}$  is the transverse sensitivity in the Y-direction.

In addition, the expressions that describe the relationships between the magnitude  $V_{\rm T}$  and the initial phase  $\phi$  of the output  $V_{\rm T}(t)$  and the amplitudes and initial phases of the X- and Y-axis accelerations are given by Formulae (B.4) and (B.5).

$$\hat{V}_{\mathrm{T}}^{2}\left(t\right) = \left(S_{\mathrm{X}}\hat{a}_{\mathrm{X}}\cos\phi_{\mathrm{X}} + S_{\mathrm{Y}}\hat{a}_{\mathrm{Y}}\cos\phi_{\mathrm{Y}}\right)^{2} + \left(S_{\mathrm{X}}\hat{a}_{\mathrm{X}}\sin\phi_{\mathrm{X}} + S_{\mathrm{Y}}\hat{a}_{\mathrm{Y}}\sin\phi_{\mathrm{Y}}\right)^{2} \tag{B.4}$$